

Attorney Docket No.: FUJI 20.624 (100794-00480)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s): Hitoshi YAMADA et al.

Confirmation No.: 1140

Serial No.: 10/657,747

Filed: September 8, 2003

Title: **RESOURCE LOAD MEASURING METHOD ...**

Examiner: Kamal B Divecha

Group Art Unit: 2151

April 18, 2008

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO OFFICE ACTION

SIR:

In response to the non-final Office Action dated January 18, 2008, Applicants respectfully submit the following: